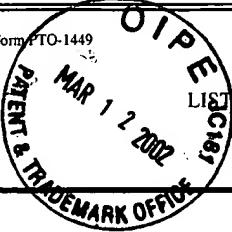


EL844055781 Sheet 1 of 1

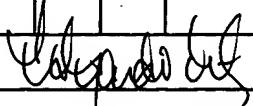
Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1741		SERIAL NO. 09/875,501	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Klaus Florian Schuegraf et al.			
					FILING DATE June 4, 2001		GROUP 2815	
U.S. PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Name			Class	Subclass	Filing Date If Appropriate
EO	AA 5,439,833	08/1995	Herbert, et al.			437	31	
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
	Document Number	Date	Country			Class	Subclass	Translation
								Yes
AL	401276761-A	11/1989	Japan - Nonaka					No
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
EO	AM	<input checked="" type="checkbox"/>	Ku et al. "The application of ion-beam mixing, coped silicide, and rapid thermal processing self-aligned silicide technology" VSLI Technology, Systems and Applications, May 17-19, 1989, Pages 337-341					
EO	AN	<input checked="" type="checkbox"/>	Lange, H.: "Physical Properties of Semiconducting Transition Metal Silicides and their Prospects in Si-Based Device Applications"; IEEE 1998; Pages 247-250.					
EO	AO	<input checked="" type="checkbox"/>	Mogami et al.; "Low-Resistance Self-Aligned Ti-Silicide Technology for Sub-Quarter Micron CMOS Devices"; IEEE 1996; Pages 932-939.					
<i>Dale Gandy</i>				<i>4/3/02</i>				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

EV026157354

Sheet 1 of 2

Form PTO-1449 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1741		SERIAL NO. 09/875,501	
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			APPLICANT Klaus Florian Schuegraf et al.			
					FILING DATE June 4, 2001		GROUP 2815	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
EO	AA	4,354,309	10/1982	Gardiner et al.			TECHNOLOGY RECEIVED MAR 21 2002 CENTER 2800	
EO	AB	4,559,091	12/1985	Allen et al.	148	174		
EO	AC	4,886,765	12/1989	Chen et al.	437	200		
EO	AD	5,192,708	03/1993	Beyer et al.	437	90		
EO	AE	5,393,676	02/1995	Anjum et al.	437	24		
EO	AF	5,712,181	01/1998	Byun et al.	437	46		
EO	AG	5,798,296	08/1998	Fazan et al.	438	592		
EO	AH	5,811,343	09/1998	Wann et al.	438	305		
EO	AI	5,985,720	11/1999	Saitoh	438	266		
EO	AJ	6,040,238	03/2000	Yang et al.	438	592		
EO	AK	5,164,333	11/1992	Schwalke et al.	437	200		
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
EO	JP 02265248 A	04/1989	Japan - Kuriyama, Hiroko				Yes	No
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
<i>W. Gandy (Signature)</i>				<i>4/3/02</i>				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449  MAR 12 2002 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					ATTY. DOCKET NO. MI22-1741	SERIAL NO. 09/875,501	
					APPLICANT Klaus Florian Schuegraf et al.		
					FILING DATE June 4, 2001	GROUP 2815	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
ED	AA	5,350,698	09/1994	Huang et al.	437	26	RECEIVED TECHNOLOGY CENTER 2800 MAR 21 2002
ED	AB	5,441,904	08/1995	Kim et al.	437	40	
ED	AC	5,481,128	01/1996	Hong	257	320	
ED	AD	6,060,741	05/2000	Huang	257	315	
ED	AE	6,208,004 B1	03/2001	Cunningham	257	413	
ED	AF	6,239,458 B1	05/2001	Liaw et al.	257	296	
ED	AG	5,767,004	06/98	Balasubramanian et al.			
ED	AH	5,840,607	11/98	Yeh et al.			
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes
							No
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
				2/3/02			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							